

Ion Sources (a glance..)

Heavy Ion Therapy Masterclass School, 17-22 May 2021, Sarajevo-Online

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Overview

PART1: General Overview Ion Sources: today

PART2: ECR Ion Sources: Friday

Overview – PART2

- Recap from previous time
- Introduction to ECR Ion Sources
- History of ECRIS
- ECRIS for Medical Applications
- Physics of ECRIS
- Summary

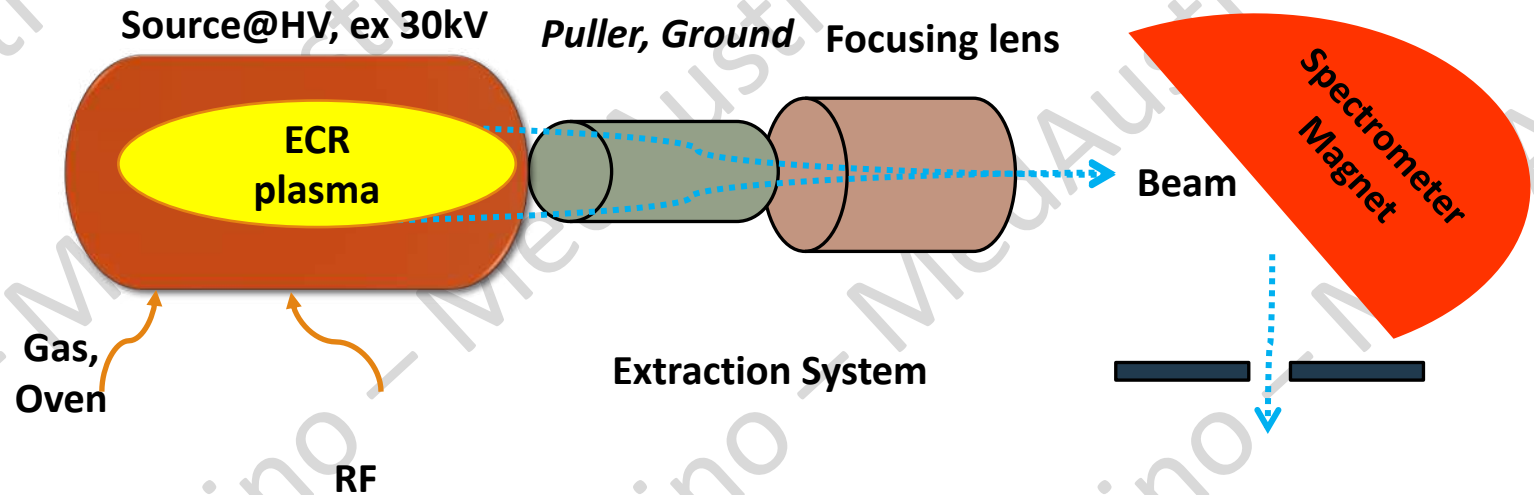
Recap

- The ion source is the first important element of any accelerator
- It generates the beam which needs to have specific requirements in terms of the fundamental parameters that were introduced on previous talk (i.e. particle type, charge state, intensity, energy, emittance)
- Depending on the application, the best source can be selected
- For medical applications, Electron Cyclotron Resonance Ion Sources (ECRIS) are good candidates to produce stable beams (charge states from 1+ to 4+, currents on the order of hundreds of uA)
- Compromise between high charge state and intensity must be always found...

What is an ECRIS?

An Ion Source where the ions are created via **Electron Cyclotron Resonance** by making use of:

1. A vacuum vessel where we inject a material/a neutral gas to create those ions
2. An RF generator to trigger the ionization process and a state of **Plasma**
3. A **sophisticated magnet** to confine the plasma (permanent, coils, superconducting..)
4. An extraction system to pull out the generated ions



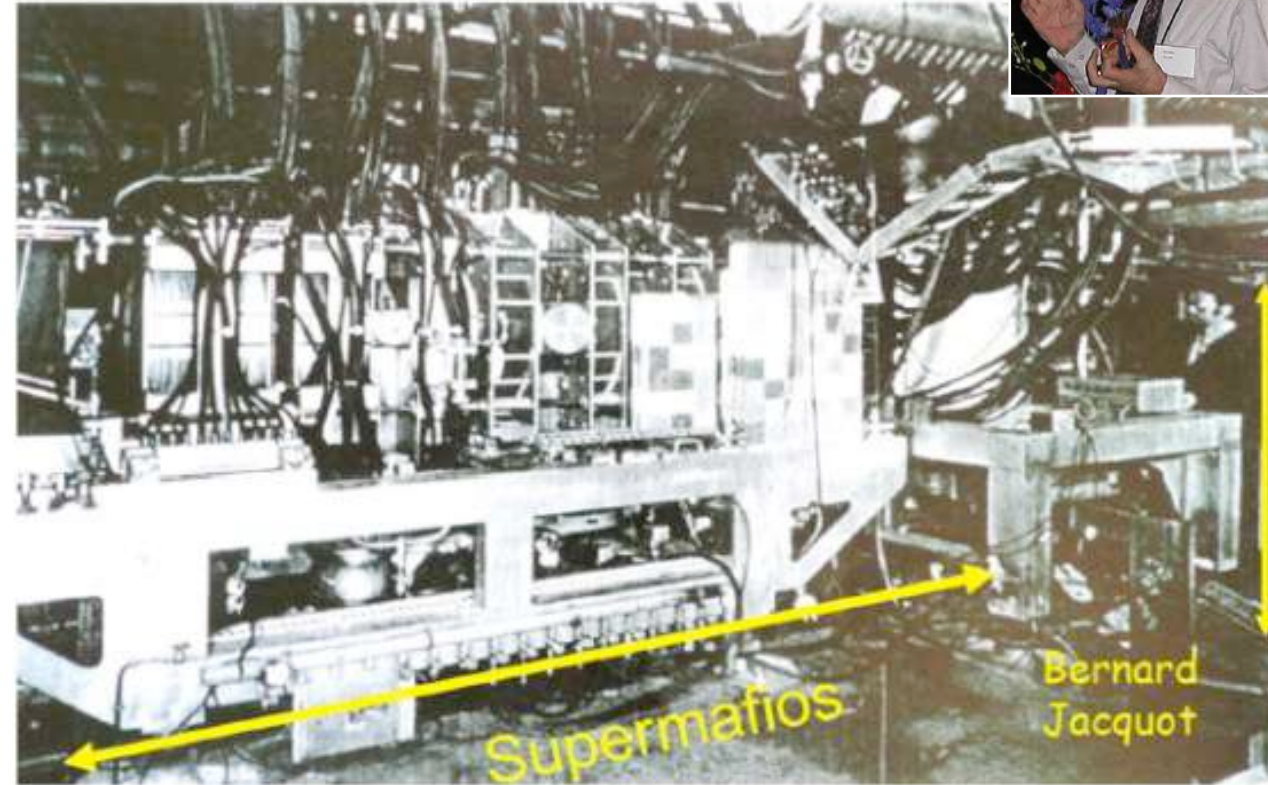
Beside that: cooling systems, magnets, vacuum pumps, racks, power supplies etc...

ECRIS – a bit of History

Richard Geller



- Invented in 1972 by R. Geller in Grenoble: converted a 3MW fusion plasma devices into ECR ion sources and succeeded in 1974 with “Supermafiors” to produce 15 μA of O^{6+} and Ar^{8+}
- The legend says that, at first power switching, an electrical black out, occurred on half of Grenoble city!
- ECRIS classified in “generation” (first, second etc.) depending on the operative conditions (RF frequency) and on the magnetic field configuration (permanent or superconductive magnets)
- There is a limitation in the performance of the ECRIS (frequency and power) so today many studies are focused on how to optimize the heating mechanism with a given frequency

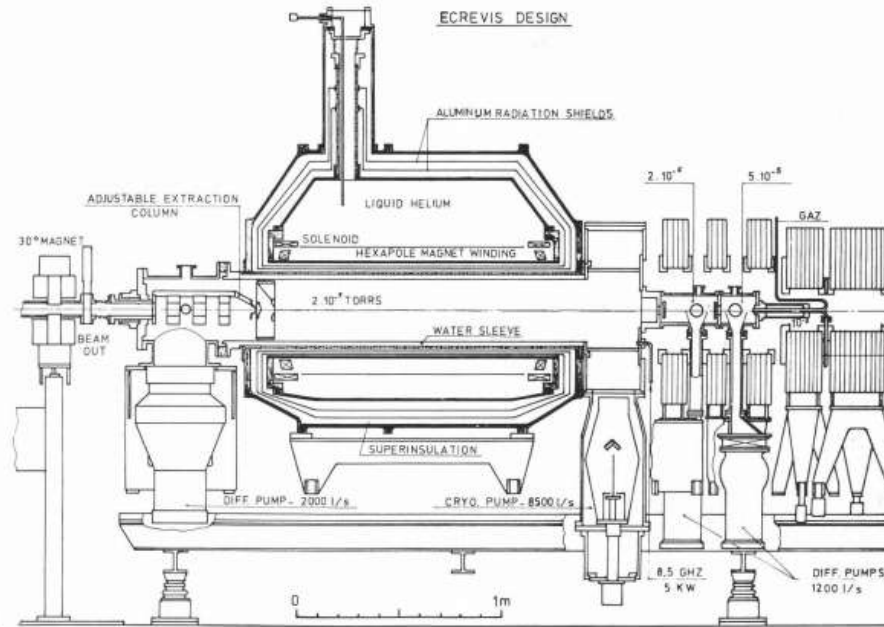


Supernanogan (II GEN, 14 GHz)

ECRIS – I, II, III Generation

ECRIS classified in “generation” (first, second etc.) depending on the operative conditions (RF frequency) and on the magnetic field configuration (permanent or superconductive magnets)

- First generation, Minimaños, ECREVIS source, (1970-1980), 100 μ A, 6^+ - 8^+ ,
- Second generation (1980-2003), ramp-up of performances, currents mA!
- Third Generation (2003...), 18-28 GHz, 3 mA O^{6+} , 0.86 mA Ar^{12+}



THE ECREVIS SOURCE STATUS REPORT Y. Jongen, C. Pirart, G. Ryckelaert

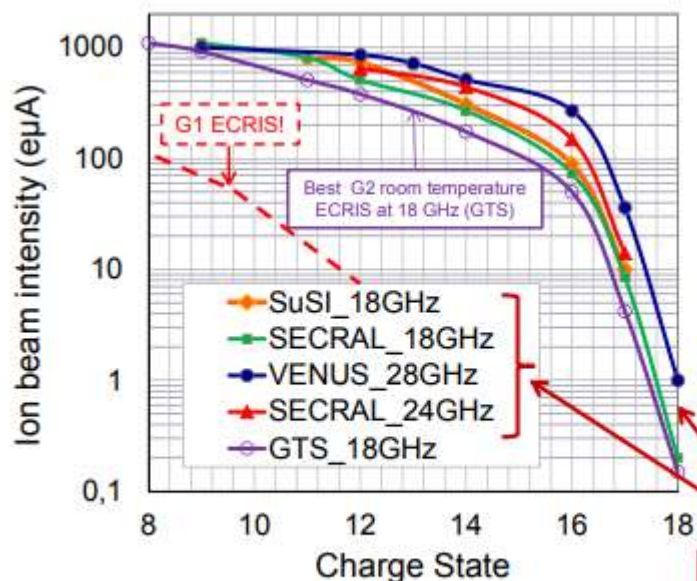


Supernanogan (II GEN, 14.5 GHz)

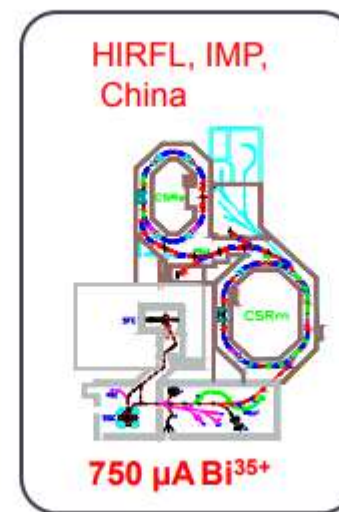
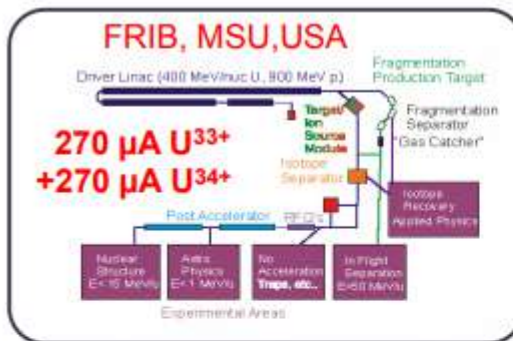
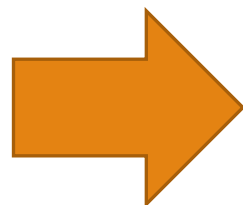


Venus Ion Source a LBNL (III GEN, 28 GHz)

Towards IV Generation



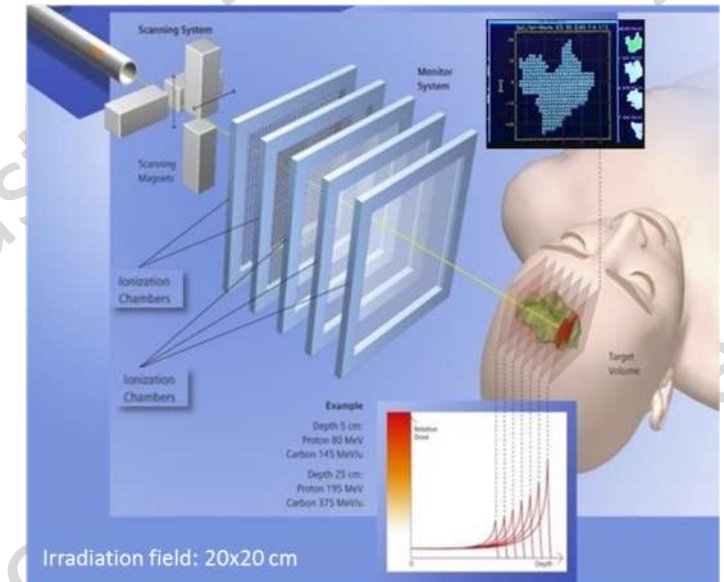
Source: G.Machicoane, MSU/NSCL, ICIS'11, modified



Source: ELECTRON CYCLOTRON RESONANCE ION SOURCES – II, Thuillier, CAS school 2012

Which IS do we need to met the Medical Requirements?

- Capable of generating a **stable** and reproducible beam 24/24 hours
- Charge state & extracted currents for clinical treatment
- “Smaller” beam emittance in order to match the beam further in the accelerator (LINAC)
- Low maintenance IS with minimum component failure and low electrical consumption
- User friendly for the Operators

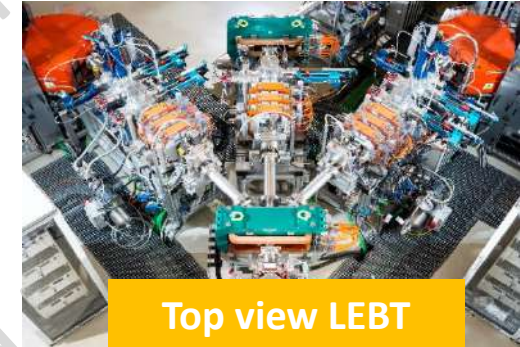


High intensity and high charge state is not the main requirement for us, II Generation already meet the requirements

Example: Supernanogans at MedAustron



Source



Top view LEBT

- Three identical ECRIS from Pantechnik always accessible
 - One dedicated to proton ion beam generation
 - One dedicated to carbon ion beam generation
 - Third source for future non-clinical research with helium
- Possibility of source switching for treatment by a switching magnet

Typ. Parameters used at MedAustron	H ⁺ Source	C ⁴⁺ Source
RF Frequency (GHz)	14.451	14.455
RF Power (W)	8-10	80-90
B _{ECR} (T)	0.5	0.5
Gas Mix	H ₂	CO ₂ +He
Ex. current	670 uA	100 uA

Physics of ECRIS

Combines the use of an RF EM force and magnetic confinement via creating a **plasma state**

The plasma is mixture of ion, electrons and atoms with specific properties

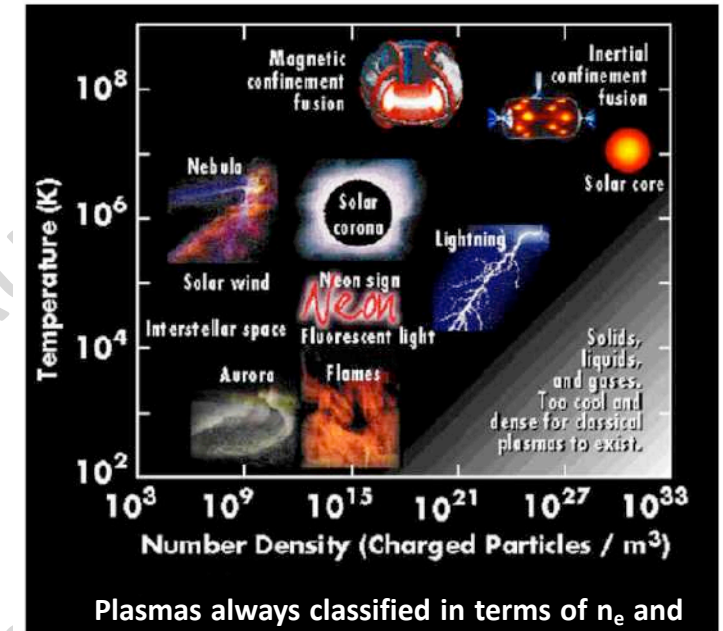
highly ionized gas with property of “quasi-neutrality” out of a certain λ_D (Debye length) , Plasma Length must be $L \gg \lambda_D$

mixture behaves like an oscillator: ions and electrons oscillate in layers with their own oscillation frequency ω_p and their own plasma potential

To create the plasma, we use an EM field (for example an RF Generator) we need to go above the critical density N_{cr} to have an efficient heating

$$\lambda_D = \left(\frac{\epsilon_0 k_B T_e}{n_e \cdot e^2} \right)^{0,5} \quad \omega_p = \omega_{pi} = \left(\frac{e^2 n_e}{m_0 \epsilon_0} \right)^{\frac{1}{2}} \quad N_{cr} = 4\pi^2 \frac{m\epsilon}{e^2} f_p^2$$

complex physics behind plasma formation (collective phenomena, atomic physics, plasma waves, ExB drifts, EM Theory)



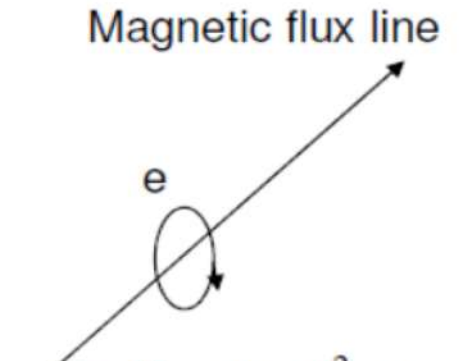
How do we trigger the ECR?

- The neutral gas injected into the vacuum vessel contains few free electrons
- The few free electrons gain energy from the RF electromagnetic wave having a certain ω_{rf} and start to collide with the neutral atoms
- The presence of the magnetic field makes the electrons spiraling around the magnetic field lines (Lorentz Force) with a certain ω_e
- Electron Cyclotron Resonance happens for:

$$\omega_e = \frac{e \cdot B}{m} = \omega_{rf}$$

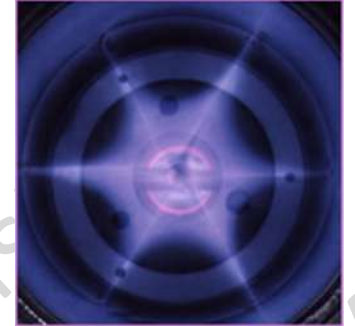
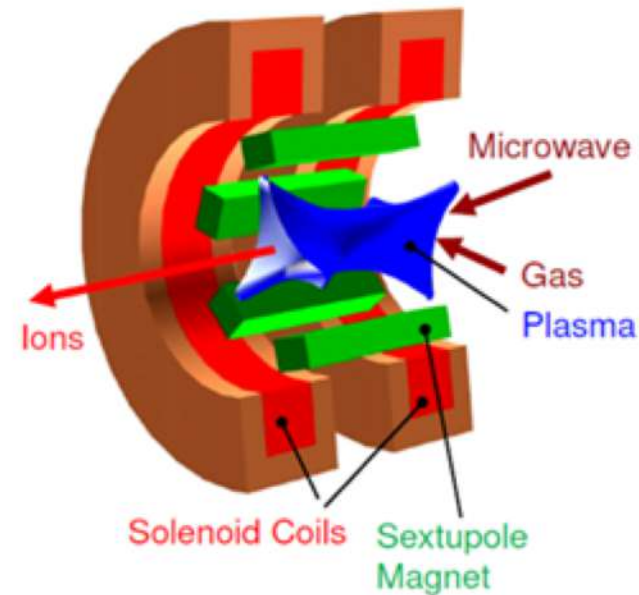


Plasma is formed


$$q \cdot v \cdot B = m \cdot \omega^2 \cdot r$$
$$\omega = \frac{v}{r}$$
$$r_c = \frac{m \cdot v}{q \cdot B}$$

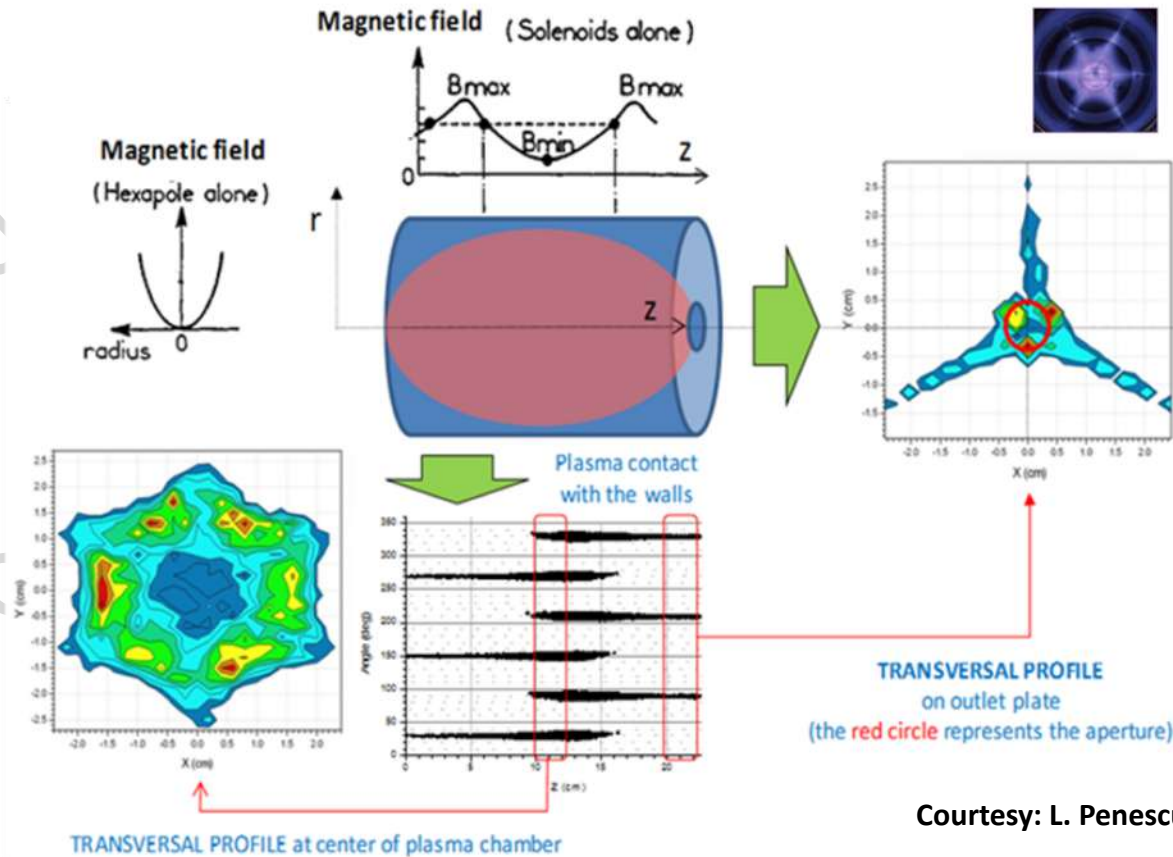
Magnetic Field Structure

- B field creates the ECR resonance, but it also confines the plasma
- B field created by a pair of solenoid (axial field) is inherently instable as the plasma fluid can 'escape' radially (**B_{\min} field**)
- **Solution:** add a radial field (sextupole) that creates a 'mirror field' in the radial direction by adding a multipole to the confinement field (can define loss cones)
- Combination of sextupole and solenoid field shapes the magnetic field lines to form a twisted triangular shape on each end of the source

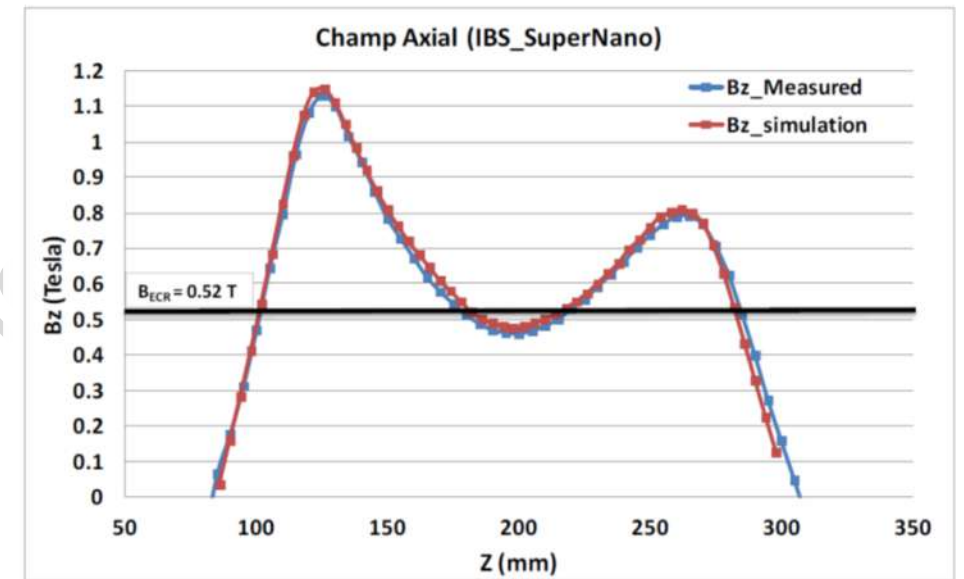


Source: USPAS-
Fundamentals of Ion
Sources 8./9. Electron
Cyclotron Resonance Ion
Sources Daniela Leitner

Magnetic Field Structure in Supernanogans



Courtesy: L. Penescu



Courtesy Pantechnik/GANIL

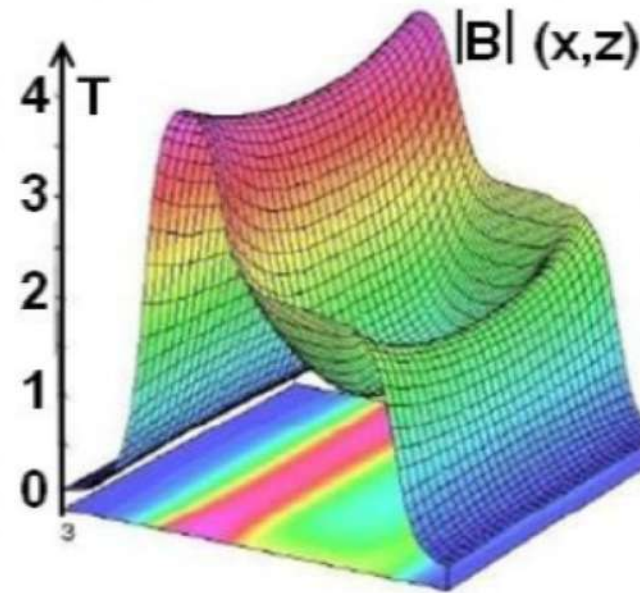


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Magnetic FIELD Structure

The magnetic field strengths need to fulfill specific laws (scaling laws from R. Geller) in order to have a stable plasma

$$\begin{aligned} B_{\text{inj}} &\sim 4 \cdot B_{\text{ecr}} \\ B_{\text{min}} &\sim 0.8 B_{\text{ecr}} \\ B_{\text{ext}} &\sim B_{\text{rad}} \\ B_{\text{rad}} &\geq 2 B_{\text{ecr}} \end{aligned}$$



Source: USPAS-
Fundamentals of Ion
Sources 8./9. Electron
Cyclotron Resonance Ion
Sources Daniela Leitner

● For medical requirements we are borderline with these laws, but it is not critical for low intensities

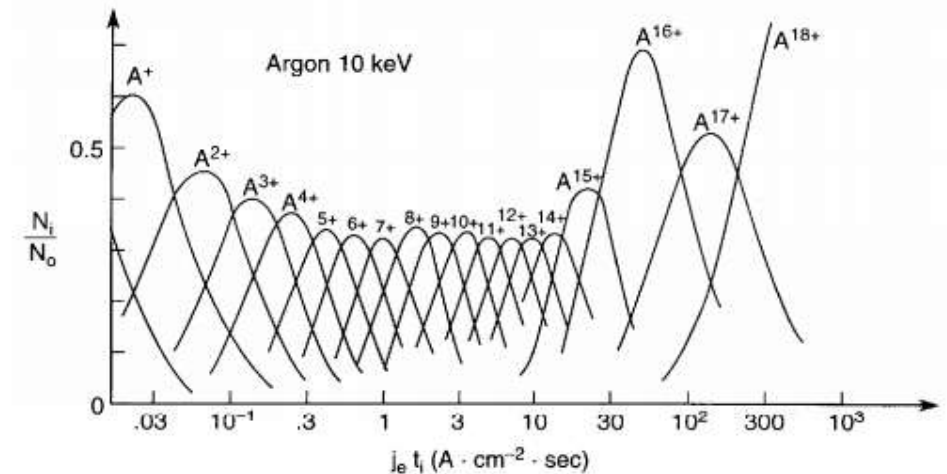
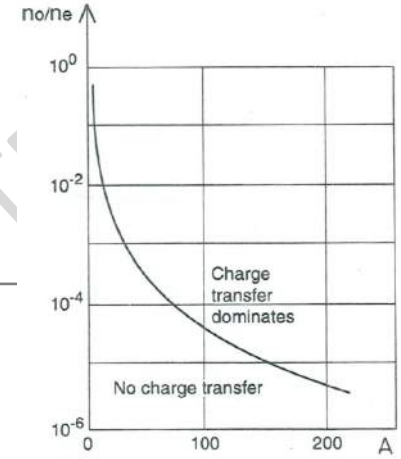
Plasma Stability

- The plasma needs to be well sustained in terms of density and temperature (atom injection)
- The amount of gas vs. the rf power (and the shape of the magnetic field) are the key components for such stability:

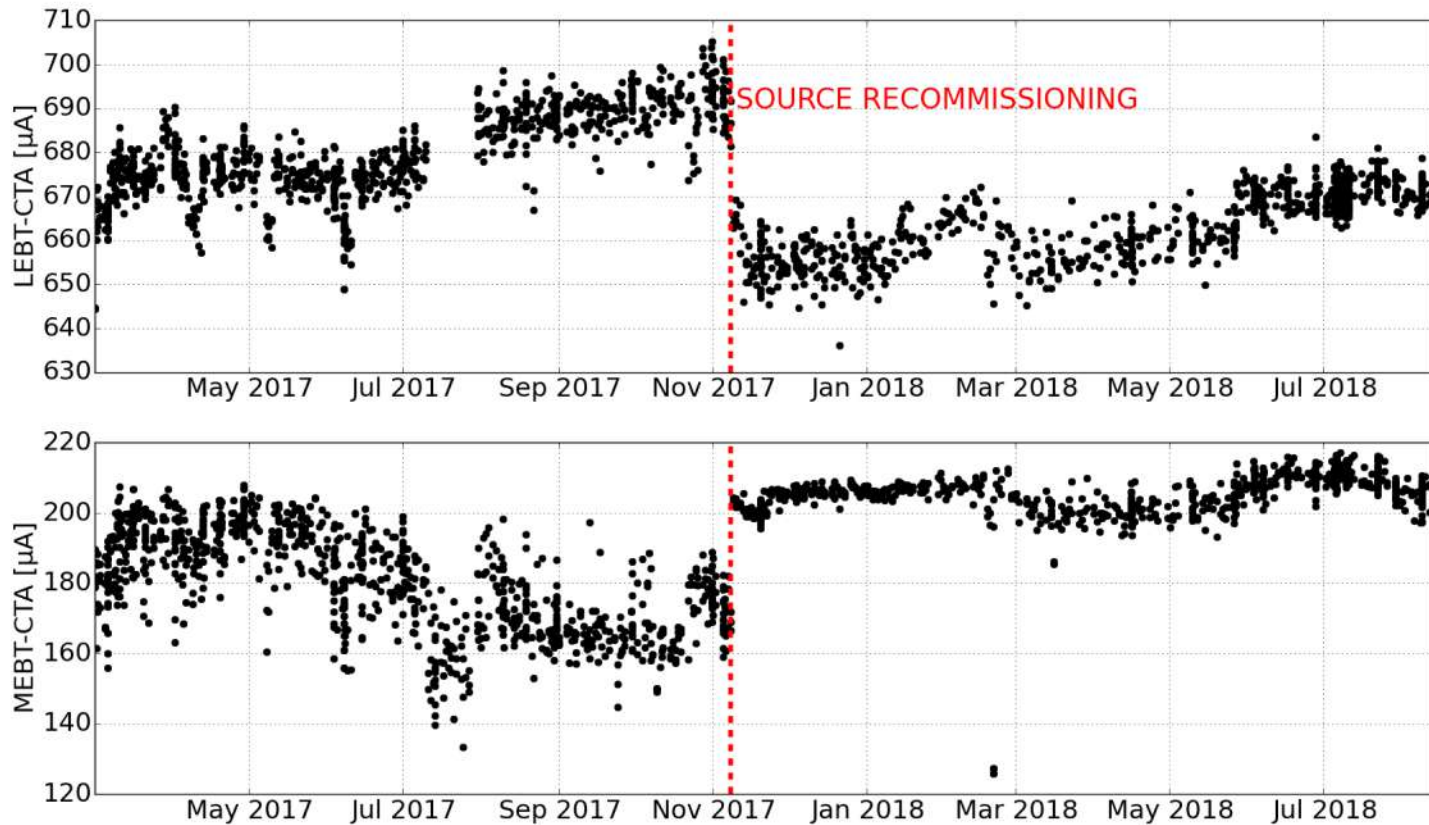
$$\text{Eff} \sim \frac{n_i}{n_0}$$

- Product of $n_e \tau_i$ can be increased with increasing microwave power, but at the cost of lower intensity..**
- Compromise has to be found in between charge state $\langle q \rangle$ and Intensity I

$$\langle q \rangle \sim \frac{n_e \tau_i}{n_e}$$



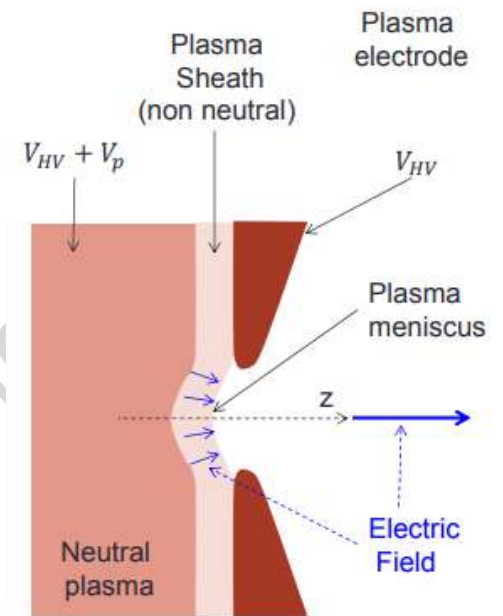
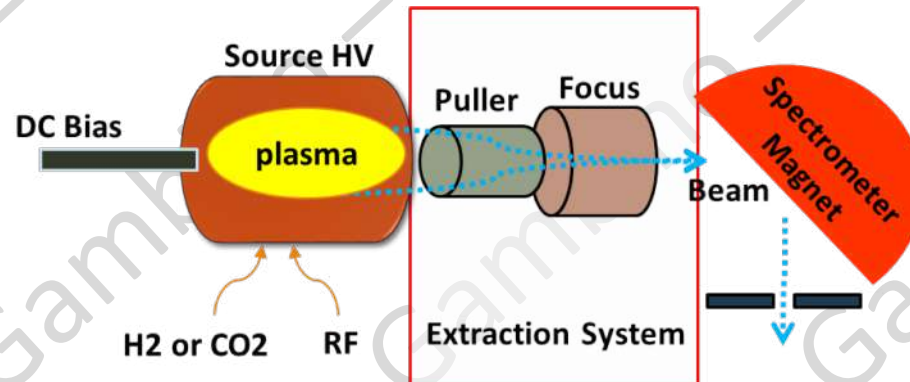
IS Stability for us translate in machine performances



- Low intensity drifts occurs over time
- Low intensity leads to longer treatment time
- Emittance can grow over time
- From time to time source has to be recommissioned in order to recover the needed intensity and improve the **shot to-shot stability**

Extraction of the beam

- Ions from the loss cone are extracted via a high potential
- Source body placed at positive HV (≈ 24 kV, i.e. 8 KeV)
- An electrode (**puller**) at ≈ 2 kV is grounded and placed at negative lower potential to favour the extraction with circular hole, an electric field generates between the source and the puller
- An electrode (**focus**) at ≈ 1.5 kV adapts the beam size to the focal point of the dipole magnet for good transmission into the beam line
- Additionally a **Bias** adds electrons to the plasma and lowers the plasma potential reducing ion losses towards the injection
- The longitudinal beam profile depends mainly on extraction parameters with respect to the plasma potential



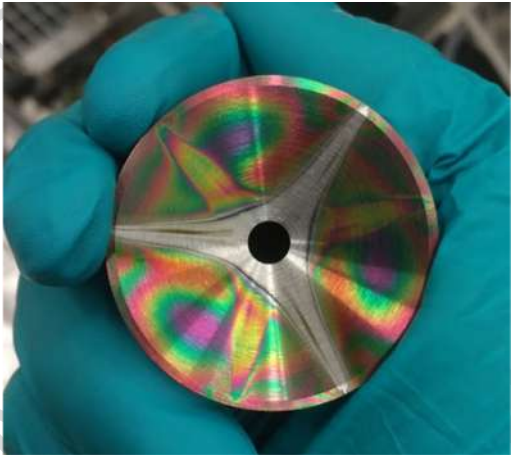
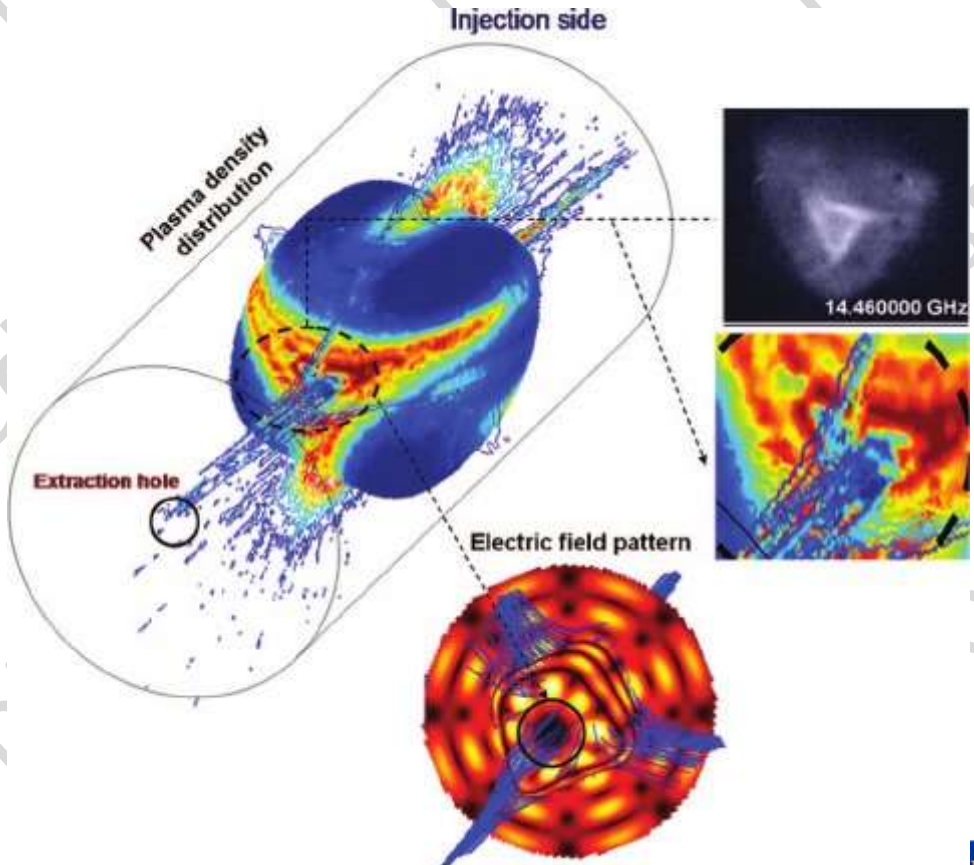
Source: ELECTRON CYCLOTRON RESONANCE ION SOURCES – II, Thuillier, CAS school 2012

Follow the Field Lines and find the Ion Beam

Some ions will always escape (loss cone), these are the ions that we extract

The hot electrons of ECRIS are a key aspect in:

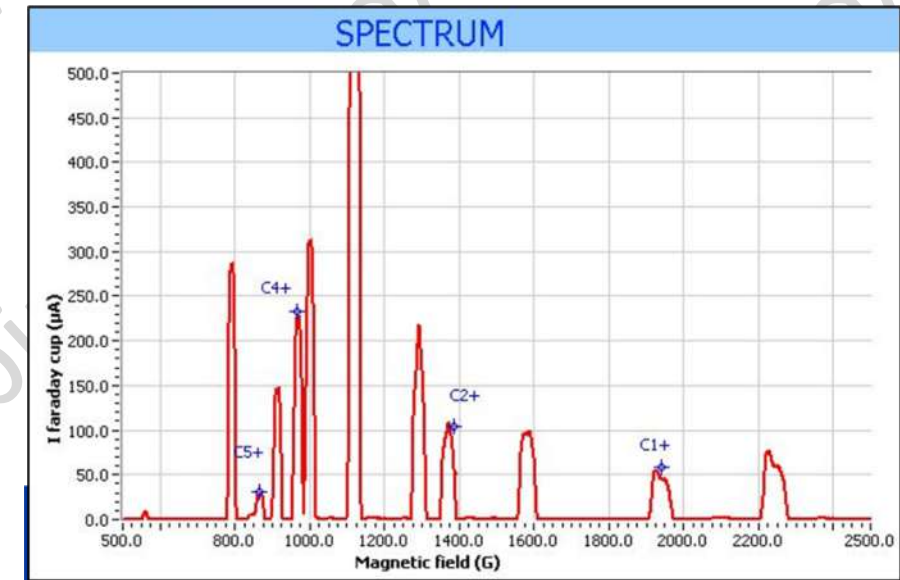
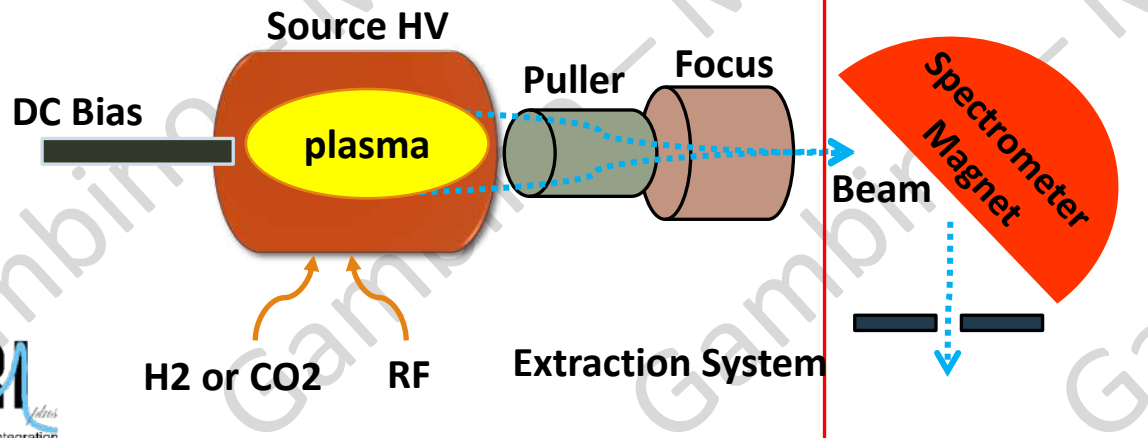
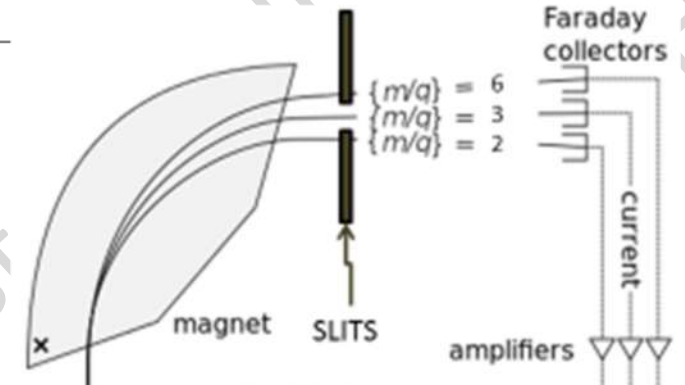
- At early plasma formation, when the ions have very low energy
- Partially neutralize the space charge induced by the ions during extraction gap penetration, until a point where they are reflected back to the source



Plasma Lens, Ion Beam Clearly visible at the extraction hole

Selection of species

- Beam is sent to dipole for charge state selection (from source all charge states)
- Extracted current is checked with FCN (invasive, blocks the beam).
- Wire scanners to check the beam profile (H and V)
- Slits to cut out the oxygen peak for carbon
- Emittance measured with slits and wire scanners



To Summarize

- ECRIS are well suited IS for medical treatment requirements
- The combination of gas injection, RF frequency and power and magnetic field creates the condition for the plasma heating
- The magnetic field profiles needs to fulfill the scaling laws in order to sustain and confine the plasma (confinement of hot electrons that ionize the atoms and confinement of the ions long enough to get multiple ionizations)
- The beam is extracted via a high potential and ion species are selected via a spectrometer magnet
- Overall source has to be built already for a specific range of charge states and intensities
- Performances can also be improved via pulsed mode operation or double frequency heating

Thanks for your attention!
